

(19) World Intellectual Property
Organization
International Bureau



(43) International Publication Date
12 May 2005 (12.05.2005)

PCT

(10) International Publication Number
WO 2005/043545 A1

(51) International Patent Classification⁷: G11C 11/15

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(21) International Application Number:
PCT/SG2004/000356

(22) International Filing Date: 26 October 2004 (26.10.2004)

(25) Filing Language: English

(26) Publication Language: English

(30) Priority Data:
60/515,994 31 October 2003 (31.10.2003) US

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(81) Designated States (unless otherwise indicated, for every
kind of national protection available): AE, AG, AL, AM,
AT, AU, AZ, BA, BB, BG, BR, BW, BY, BZ, CA, CH, CN,
CO, CR, CU, CZ, DE, DK, DM, DZ, EC, EE, EG, ES, FI,
GB, GD, GE, GH, GM, HR, HU, ID, IL, IN, IS, JP, KE,
KG, KP, KR, KZ, LC, LK, LR, LS, LT, LU, LV, MA, MD,
MG, MK, MN, MW, MX, MZ, NA, NI, NO, NZ, OM, PG,
PH, PL, PT, RO, RU, SC, SD, SE, SG, SK, SL, SY, TJ, TM,
TN, TR, TT, TZ, UA, UG, US, UZ, VC, VN, YU, ZA, ZM,
ZW.

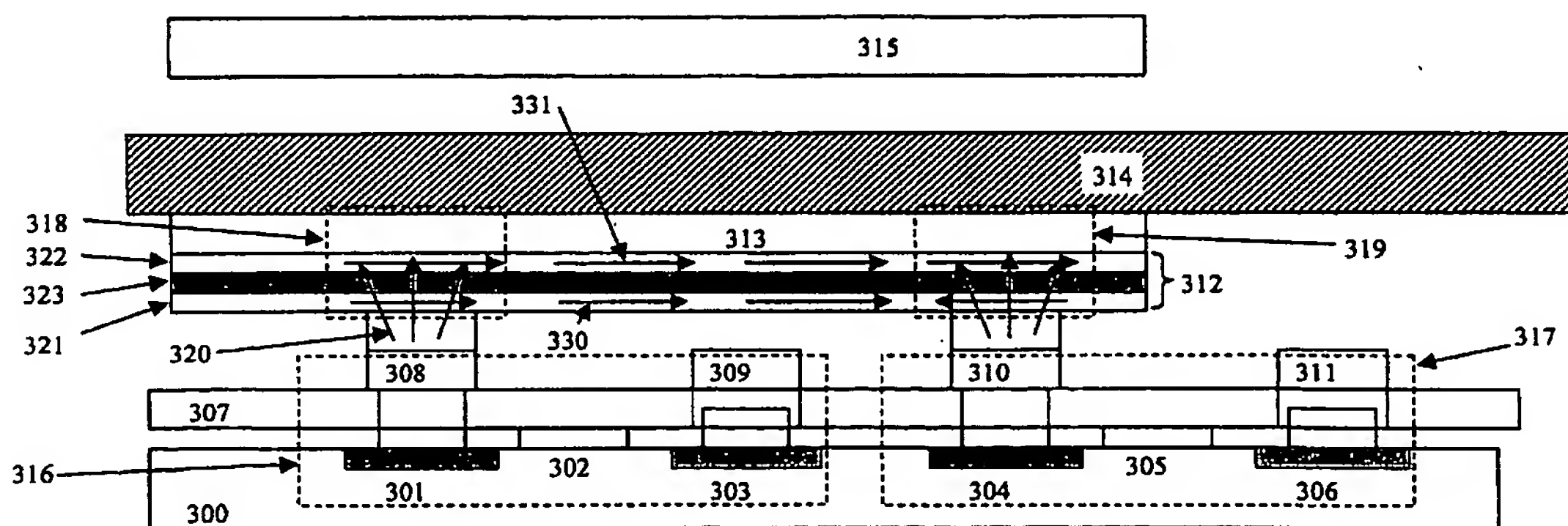
(84) Designated States (unless otherwise indicated, for every
kind of regional protection available): ARIPO (BW, GH,
GM, KE, LS, MW, MZ, NA, SD, SL, SZ, TZ, UG, ZM,
ZW), Eurasian (AM, AZ, BY, KG, KZ, MD, RU, TJ, TM),
European (AT, BE, BG, CH, CY, CZ, DE, DK, EE, ES, FI,
FR, GB, GR, HU, IE, IT, LU, MC, NL, PL, PT, RO, SE, SI,
SK, TR), OAPI (BF, BJ, CF, CG, CI, CM, GA, GN, GQ,
GW, ML, MR, NE, SN, TD, TG).

Published:

— with international search report

[Continued on next page]

(54) Title: NANO-CONTACTED MAGNETIC MEMORY DEVICE



(57) Abstract: A magnetic memory device includes a plurality of transistors (316, 317) formed on a substrate and a common mag-
netic memory block (312) including multiple effective magnetoresistive elements (318, 319), a ferromagnetic recording (321), a
non-magnetic space (323), and a free magnetic reading (322) layer formed above the transistors (316, 317). An extended common
digital line (315) is located above the common magnetic memory block (312). The common magnetic memory block (312) is elec-
trically connected with a respective source/drain electrode of the transistors (316, 317) through each a contact at a respective active
area. The specific magnetization state of the ferromagnetic recording layer at the active areas can be changed by a heating process
and applying an external field induced from the common digital line (315) and the bit (309, 311) or word (307) or word (307) lines.
The change in resistance of the effective magnetoresistive element (318, 319) can be detected by means of changing the magnetiza-
tion state of the free magnetic reacting layer during reading, thus a smaller switching field is required.



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